

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s):	Yoshiaki Mori, et al.	Art Unit:	1795
Serial No.:	10/026,286	Examiner:	Daborah Chacko Davis
Filed:	December 20, 2001	Confirmation No.:	1796
Title:	Pattern Forming Method and Apparatus Used for Semiconductor Device, Electric Circuit, Display Module, and Light Emitting Device		

**RESPONSE F**

Sir:

In response to the Office Action dated January 23, 2008, please amend the above-identified application as follows: